

# **Short Intro about the creation of a maskless lithography lab in Kyiv in the framework of the NRFU project**

*Wednesday, November 6, 2024 8:15 AM (10 minutes)*

## **Type of presence**

**Presenter:** Prof. DZHAGAN, Volodymyr (Lashkaryov Institute of Semiconductor Physics (ISP), NAS of Ukraine)

**Session Classification:** Workshop on Direct Optical Lithography for Advanced Opto- and Microelectronics